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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KIMURA, et al.
Serial No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE, MANUFACTURING METHOD OF THE SAME,
SEMICONDUCTOR DEVICE AND ELECTRONIC DEVICE
Group: 2813
Examiner: Laura M. Schillinger

NOTICE OF APPEAL**Mail Stop: AF**

Commissioner for Patents
POB 1450
Alexandria, VA 22313-1450

December 5, 2005

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the decision in the Final Office Action, dated August 5, 2005, of the Primary Examiner, finally rejecting claims 3 and 4.

The items checked below are appropriate:

- ☒ A Petition for Extension of Time, including a Credit Card Payment form for the required fee, is filed concurrently herewith.
- ☒ The Appeal Fee of \$500 is also included in the attached Credit Card Payment form.

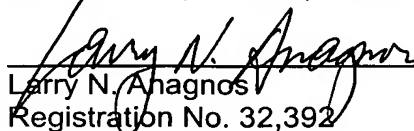
Please charge any shortage in fees due in connection with the filing of this Notice of Appeal, including extension of time fees, to Deposit Account No. 01-2135 (attorney docket No. 219.37079X00) and please credit any excess fees to such deposit account.

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Respectfully submitted,
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